



Docket No. 0008-FA-  
J617 PCT/PTO 27 APR 2001 PCT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Re Application of Hunt et al.

Group Art No. 1762 ( U.S. parent)

- ✓ U.S. Application No. 09/748,714 (U.S. National filing)  
✓ PCT Application No. PCT/US00/15416 (PCT filing)

Filed: 21 December 2000

For: CHEMICAL VAPOR DEPOSITION METHODS FOR MAKING  
POWDERS AND COATINGS, AND COATINGS MADE  
USING THESE METHODS

**Request to Consolidate Searching**

Assistant Secretary and Commissioner of Patents and Trademarks  
Washington D.C. 20231

The Above-Identified application was filed both as a U.S. national application and a PCT application on 21 December 2000. The applications are identical.

A copy of this Request is being sent to for entry on both the U.S. national file and the PCT file.

The U.S. Patent Office has been designated as the International Searching Authority.

To avoid duplication of effort and costs, it is requested that the national and international searches be coordinated and to be done by the same examiner.

5 April, 2001

Wayne E. Nacker  
Wayne E. Nacker, Reg. 29,571

CUSTOMER NO. 24948

I, Wayne E. Nacker, hereby certified that this document and the documents listed above were deposited with the U.S. Postal Service on 5 April, 2001, postage paid, addressed to the Assistant Commissioner for Patents, Washington D.C. 20231

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